

The FIB-SEM as 3D Nanoprinter Overview of the Activities in Graz



<u>R. Winkler¹*, M. Brugger-Hatzl², L. Seewald¹, D. Kuhness¹, D. Loibner¹, D. Müller¹, S. Rauch³, V. Reisecker³, A. Weitzer³ and H. Plank^{1,2,3}</u>

1. Christian Doppler Laboratory DEFINE, Graz University of Technology, 8010 Graz, Austria 2. Graz Centre for Electron Microscopy, 8010 Graz, Austria

3. Institute of Electron Microscopy and Nanoanalysis, Graz University of Technology, 8010 Graz, Austria

Introduction

3D printing and additive manufacturing are important areas in research and development. While 3D printing at the macro-scale down to the micro-scale has found its way to industry, real 3D printing of nanoscale



objects is still a challenging task (Fig. 1). Electron/Ion Beam Induced Focused Deposition in FIB-SEM Microscopes allows the controlled direct-write fabrication of 3D nano-objects with unique advantages in terms of feature size, design complexity, minimal substrate demands, and possible materials / functionalities.

The 3D Nanoprinting Technique: 3D-FEBID

To grow freestanding 3D wires via 3D-FEBID (Focused Electron Beam Induced Deposition, Fig. 2), a gaseous precursor is continuously injected inside a FIB/SEM vacuum chamber and locally immobilized by electron stimulated dissociation of surface adsorbed precursor molecules.



Figure 2: The principle of the 3D-FEBID process for the fabrication of freestanding wires^[2]. The electrons dissociate the adsorbed precursor and locally immobilize fragments. The stationary pulse duration (dwell time) and the beam displacement (point pitch, Δx) determine the inclination angle of the nanowire.

Research Areas Related to FEBID at the TU Graz

At the FELMI-ZFE we currently address different aspects of 3D-FEBID:

Shapes different We explore geometries from planar (2D) deposits over bulky 3D-objects towards real, freestanding 3D. For the latter, focus is put on the optimization of meshedand closed-structures but also their combinations.



Materials

material properties The of the deposits can be optimized by variation of precursor/beam/process parameters by and applying different posttreatment procedures.

The application 3Dof FEBID for novel **AFM tips** concepts is explored in a

Applications

We explore and evaluate 3D-FEBID concepts such as 3D NEMS resonators, plasmonics, scanning probes and others.

dedicated project: Christian Doppler Laboratory for Direct-Write Fabrication of 3D Nano-Probes.

Figure 3: Research areas at TU Graz related to Focused Electron Beam Induced Deposition (FEBID) and in particular to 3D-FEBID. Shape: Special shaped pillars (defocus pillar)³, nano-sponge (meshed objects)⁴, semi-closed petals (walls)⁵, spiral phase plate (bulky 3D)⁶, FEBID QR-code (2D). <u>Materials</u>: Multi-material deposition (precursor type), TEM-tomography of cured FEBID pillar (e-beam curing)⁷, freestanding Au- nanowires (purification)⁴. <u>Applications</u>: plasmonic active 3D object (plasmonics)⁴, NEMS resonator-bridge for gas sensing (sensors)⁸.

The fundamental research on 3D-nanoprinting in the FIB are combined to develop advanced probes for Atomic Force Microscopy (AFM) in the Christian Doppler Laboratory.

Conductive AFM (CAFM)

In C-AFM, a conductive AFM tip scans the changes in the surface to map local conductivity. With 3D-FEBID, a hollow PtC_x cone is deposited at the tip region onto an electrode of a cantilever and post-processed for transfer in fully metallic materials. The absence of any coating provides an excellent tip radius (<10 nm) as needed for high-resolution AFM images.



50 nm

Magnetic Force Microscopy (MFM)

Magnetic stray fields perpendicular to the surface can be measured in Magnetic Force Microscopy by a magnetic tip and a two-pass AFM technique. 3D-printed Co₃Fe cones show results compared superior to coated commercial tips due to the small tip radius.



Figure 5: Magnetic Co₃Fe cone as AFM tip (a, inset shows a TEM image of the to map tip apex) the height and

Scanning Thermal Microscopy (SThM)





FM cantilever tip

For measuring the local temperature, a PtC_x tetrapod is deposited between two, pre-structured electrodes. An electrical current is send through the small nano-bridge, which quickly changes its resistance as function of local surface temperatures.

Figure 6: 3D-FEBID based concept of



Figure 4: topography (a) and conductive (b) map of HOPG sample

with conductive precipitates and Sb-particles. Hollow Pt cone (full (c) and FIB-cut (d)). (e) TEM image of the purified high-resolution tip.

magnetic properties Co/Pt (b) of а multilayer sample. MFM-Phase 800.0 nm (c) and (d) show a comparison of a standard MFM tip with a FEBID tip.

Conclusion



Scanning Thermal Microscopy, where a probes the surface bridge structure (morphology and temperature), whereas the resistivity varies with the local temperature.^[9]

The resistivity of the 3Dprinted nanobridge sensitively depends on the local substrate temperature (NTC), allowing fast and reversible temperature sensing.

Acknowledgements References Contact Thanks go to the all actual and previous group members [1] Hirt et al., *Adv. Mater.* 29, 17 (2017) [6] Béché et al., Micron 80 (2016) robert.winkler@felmi-zfe.at work group of Prof. Plank, to the FELMI-ZFE team, all [7] Trummer et al. ACS ANM 2 (2019) harald.plank@felmi-zfe.at [2] Winkler et al., J. Appl. Phys. 125 (2019) [8] Arnold et al. Adv. Funct. Mater. (2018) scientific collaboration partners and our partners from [3] Kuhness et al., ACS AMI 13 (2021) [4] Winkler et al., ACS AMI 9 (2017) [9] Sattelkow et al., ACS AMI 11 (2019) industry, as well as the funding organizations. www.felmi-zfe.at Christian Doppler [5] Weitzer et al., *ACS AEM* 4 (2022) Forschungsgesellschaft